



PATENT  
005018USA  
7828.7056

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of ) Examiner: W. David Coleman  
Tepman, et al. )  
Serial No.: 10/074,854 ) Art Unit: 2823  
Filed: February 11, 2002 )  
For: VARIABLE FLOW DEPOSITION APPARATUS AND METHOD IN  
SEMICONDUCTOR SUBSTRATE PROCESSING

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the office action mailed September 22, 2003 in the above-identified application. The requested period of extension is one month, from December 22, 2003 to January 22, 2004.

A check in the amount of \$110 to cover the extension fee is enclosed. The Commissioner is authorized to charge any additional fees which may be required, or to credit any overpayment, to Deposit Account 50-0585. A copy of this letter is enclosed.

Respectfully submitted,

William K. Konrad, Reg. No. 28,868  
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(Date)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.